

Form PTO-1449 <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> (Use several sheets if necessary)	Docket Number (Optional) <b>3965.4US (94-0194.04/US)</b>	Application Number <b>Not yet assigned 10/706,244</b>
	Applicant <b>Ravi Iyer</b>	
	Filing Date <b>November 12, 2003</b>	Group Art Unit <b>2825 Unknown</b>

### U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>CME</i>	4,925,813	05/1990	Autier et al.	I	I	
<i>CME</i>	5,052,339	10/1991	Vakertis et al.			
<i>CME</i>	5,094,711	03/1992	Narasimhan et al.			
<i>CME</i>	5,260,107	11/1993	Kawamura et al.			
<i>CME</i>	5,344,792	09/1994	Sandhu et al.			
<i>CME</i>	5,645,900	07/1997	Ong et al.			
<i>CME</i>	5,665,431	09/1997	Narasimhan			
<i>CME</i>	5,846,881	12/1998	Sandhu et al.			
<i>CME</i>	5,946,594	08/1999	Iyer et al.			
<i>CME</i>	6,184,136	02/2001	Iyer et al.			
<i>CME</i>	6,340,637	01/2002	Iyer et al.			
<i>CME</i>	6,653,234	11/2003	Iyer et al.			

### FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

### OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

<i>CME</i>		D. Kim et al., "Properties of TiN-TiC Multilayer Coatings Using Plasma-Assisted Chemical Vapor Deposition," Surface and Coatings Technology, Vol. 116-119, pp. 906-10 (9/1999).

EXAMINER <i>C. Juerkett</i>	DATE CONSIDERED <i>7/16/04</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance. Include copy of this form with next communication to the applicant.